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AUTHOR(S):
Tomita, Takuro; Matsuo, Shigeki; Okada, Tatsuya; Kimoto, Tsunenobu; Matsunami, Hiroyuki; Mitani, Takeshi; Nakashima, Shin-Ichi

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Deep-ultraviolet micro-Raman investigation of surface defects in a 4H–SiC homoepitaxially grown film

Takuro Tomita and Shigeki Matsuo
Department of Ecosystem Engineering, The University of Tokushima, Tokushima 770-8506, Japan

Tatsuya Okada
Department of Mechanical Engineering, The University of Tokushima, Tokushima 770-8506, Japan

Tsunenobu Kimoto and Hiroyuki Matsumami
Department of Electronic Science and Engineering, Kyoto University, Kyoto 615-8510, Japan

Takeshi Mitani and Shin-Ichi Nakashima
National Institute of Advanced Industrial Science and Technology, Tsukuba Central 2, Ibaraki 305-8568, Japan

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The structures of comet defects in a 4H–SiC homoepitaxially grown film are investigated by deep-ultraviolet micro-Raman spectroscopy. Spatial distribution of the 4H- and 3C–SiC is clearly distinguished both from the intensities of the folded longitudinal acoustic phonon mode and the peak energies of the nonfolded longitudinal optical phonon mode. The mappings of these parameters indicate the existence of two types of comets. The mechanisms of heteropolytypic inclusion in comets are discussed. © 2005 American Institute of Physics. [DOI: 10.1063/1.2142080]

Silicon carbide (SiC) is a promising material for the high-power, high-temperature, and high-speed devices, because of its wide valence to conduction band gap. When the SiC Schottky diodes having kV-class blocking voltage are fabricated, their ON-resistance will be lowered by at least two orders of magnitude than that of similar devices made of silicon. This leads to the drastic reduction in power consumption of the diode. In the homoepitaxial growth of 4H–SiC films, however, the unintentionally produced defects called “comets” considerably degrade the breakdown voltage of SiC diode. Thus, comets are regarded as the device-killing defects. Although recent progress in the growth techniques have drastically reduced the density of comets in the films homoepitaxially grown on (0001) 8°-off wafers, comets in the films homoepitaxially grown on the 3.5°-off or nearly on-axis wafers still have been observed and gives the serious effect on electrical properties.

Some studies of heteropolytypic inclusion in the homoepitaxially grown films have been reported. Recently, Okada et al. reported the observations of comets by conventional transmission electron microscopy (TEM). While TEM provides information on defect structure with an orientated transmission electron microscopy (TEM). The details of this measurement were about 10 μm. The measurements were done in the backscattering geometry. The scattered light was filtered by a subtractive double monochromator (Photon design), then spectrum was detected by a single spectrometer (Sopra UHRS F1500) with a liquid nitrogen cooled charge coupled device detector (Roper Scientific Spec-10:256e/ln). The experimental error of this detection system is about 1 cm⁻¹. The details of this experimental setup were described in Ref. 13. The sample used in this experiment was a 4H–SiC epitaxially grown film with a thickness of 9 μm which was grown on an n-type substrate by chemical vapor deposition in a SiH₄–C₆H₆–H₂ system at 1500 °C. For the growth of the homoepitaxial film, the step-controlled epitaxy was adopted. The substrate of this film was a 4H–SiC single crystal wafer off-cut (off-oriented) from the exact (0001) plane by 8°, while keeping projection of the [1120] direction.

Electronic mail: tomita@eco.tokushima-u.ac.jp
Results are not shown in Fig. 1, the intensity of FTO/H20849 drastically lower at the inside of the comet. Although the FLO/H20849 transverse optical spectrum at the inside of it differs from that of 4H–SiC. The peak energies and the intensities of the FLA at the outside of it. The peak energies and the intensities of the FLA are plotted. The solid and dotted lines correspond to the spectra at the inside and the outside of the comet I, respectively. The spectra are shifted along the ordinate for a convenient display. The intensity of the position of probed spot. In Fig. 2, we will show the two types of position dependence as a function of normalized position for comet I and II. In the following, we will focus on the intensities of the FLA(4/4) mode and the energies of the FLO(0) mode are plotted as a function of the position of the probed spot. The plot (b-I) is for the comet I and the (b-II) is for the comet II.

DUV micro-Raman spectra for a comet are shown in Fig. 1. The solid line correspond to the spectrum at the inside of the comet, and the dotted line corresponds to the spectrum at the outside of it. The peak energies and the intensities of FLA(4/4) mode are of the spectrum at the outside of the comet agree well with those of the bulk 4H–SiC. However, the spectrum at the inside of it differs from that of 4H–SiC. Here, FLO (FLA) stands for a folded longitudinal optical (acoustic) phonon mode and FTO (FTA) stands for a folded transverse optical (acoustic) mode. The energies of the FLO(0) mode of the inside was higher than that of the outside by 8 cm⁻¹ and the intensities of the FLA(4/4) mode was drastically lower at the inside of the comet. Although the results are not shown in Fig. 1, the intensity of FTO(0) mode was also much higher at the inside of the comet. These differences clearly indicate the presence of 3C–SiC at the inside of the comet. While the peak energies of the FLO(0) mode and the intensities of the FLA(4/4) mode are different, the difference of spectral shapes could not be detected for all the probed area. These results indicate that the interface between 3C- and 4H–SiC regions is abrupt. The existence of stacking faults around the interface could not be detected. In the spectrum of 3C–SiC, the small contribution of 4H–SiC was also observed. This is because the spatial resolution of this experiment was relatively larger than the structure of comet.

In order to examine the spatial distribution of polytypes, Raman spectra were measured from the top to the tail of the comets. Here, we introduce the normalized scale to specify the position of probed spot. In Fig. 2(a), an optical micrograph of a comet is shown. The normalized scale is shown under the comet; the top and the end of the comet is set to 0 and 1, respectively. The Raman spectra just on the top of comets (normalized position is 0) were not measured because of the rough surface.

We have measured the position dependence of Raman spectra in comets can be classified into two types: types I and II. In Fig. 2, we will show the two types of position dependence as a function of normalized position for comet I and II. In the following, we will focus on the intensities of the FLA(4/4) mode and the energies of the FLO(0) mode for simplicity. In Fig. 2(b), the intensities of the FLA(4/4) mode and the energies of the FLO(0) mode are plotted as a function of normalized position. Figure 2(b-I) shows the results for the comet I (type I), and Fig. 2(b-II) shows the results for the comet II (type II). In these figures, the intensities of the FLA(4/4) mode are plotted by filled circles with solid lines and the energies of the FLO(0) mode are plotted by filled squares with broken lines.
Hallin et al. reported the 3C–SiC inclusion in triangular stacking faults (TSFs). The reported width of sandwiched 3C–SiC layer is 80 nm for TSFs. They concluded that the 3C inclusion is caused by the stacking faults. In comets, however, the included 3C layer is much thicker than that of TSFs, and most of the comets include 3C all inside of it (type I). These thick 3C inclusions cannot be explained by the stacking faults due to the electronic origin. The possible origin of comets is the anomalous growth of 3C layers that are caused by the point defects or the inclusions on the surface of substrate. These nucleuses on the surface disturb the flow of growth gases. As the growth conditions are changed due to the disturbed flow, the heteropolytypic growth will be caused. In other words, comets will be generated by this disturbed flow in the homoepitaxially grown films.

In conclusion, DUV micro-Raman spectra were measured for comets on 4H–SiC homoepitaxially grown film. At the inside of the comets, the spectra of 3C–SiC was observed. It was also found that the polytype distribution of comets is classified into two. The thickness of 3C–SiC layers is determined from the measurement, and the formation mechanism of heteropolytypic inclusion in comets is discussed. Our results demonstrated that the DUV micro-Raman spectroscopy is a powerful tool for investigating the surface structures and surface defects.

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17In this report, according to the precedent, we will denote the folded transverse (longitudinal) acoustic and optical phonon modes as PTA (FLA) and FTO (FLO), respectively. The number in the parentheses is the reduced wave vector of the corresponding phonon in the Brillouin zone of 3C-SiC.